

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Mei Wen et al.  
Serial No. : 10/676,208  
Filed : October 1, 2003  
For : METAL DEPOSITION PROCESS WITH PRE-CLEANING  
BEFORE ELECTROMECHANICAL DEPOSITION  
Examiner : Edna Wong  
Group Art Unit : 1753

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CORRECTED SECTION IN RESPONSE TO  
NOTICE OF NON-COMPLIANT AMENDMENT**

Sir:

In response to the Notice of Non-Compliant Amendment mailed June 4, 2007, in connection with the above identified application, Applicants submit the Corrected Amendment Section as follows:

**Corrected Amendment Section** begins on page 2 of this paper.  
**Remarks** begin on page 7 of this paper.